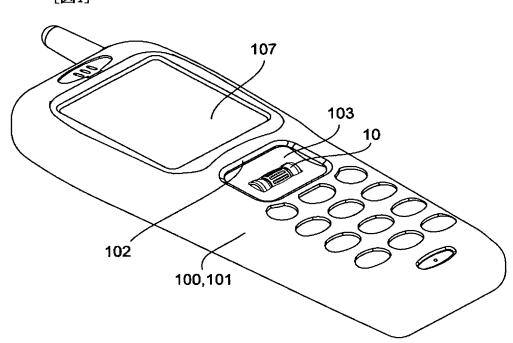
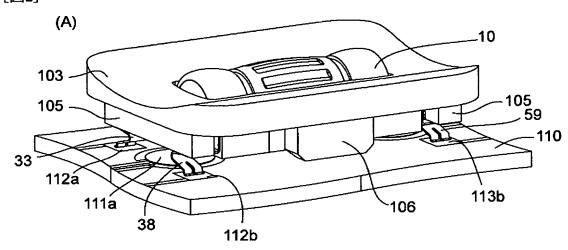
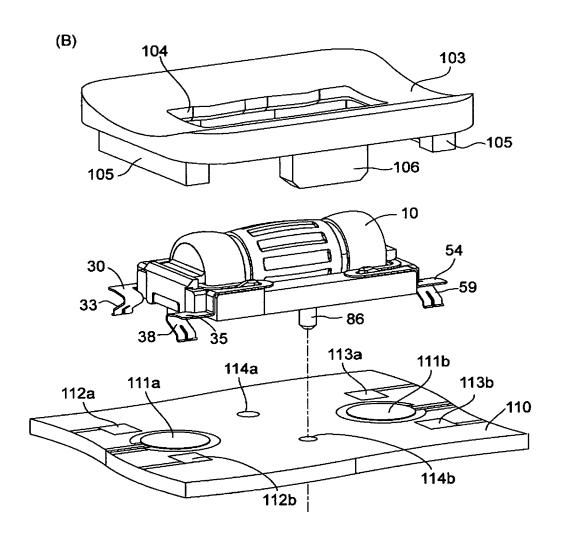
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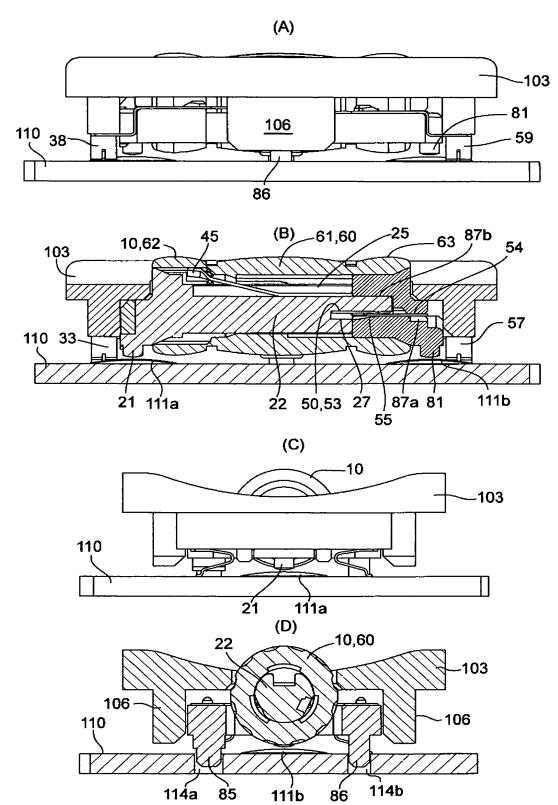




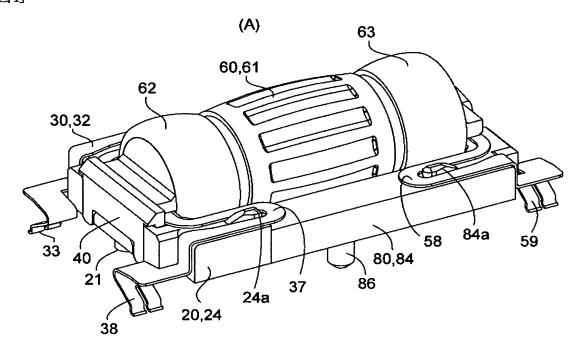


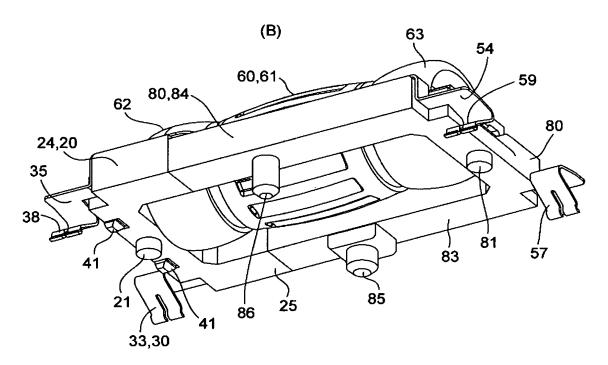
WO 2005/038843 3/27 PCT/JP2004/015059

[図3]

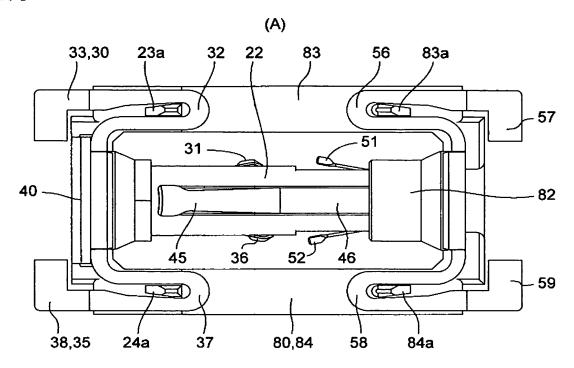


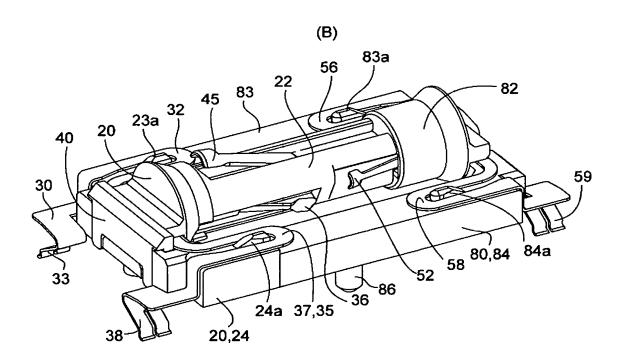
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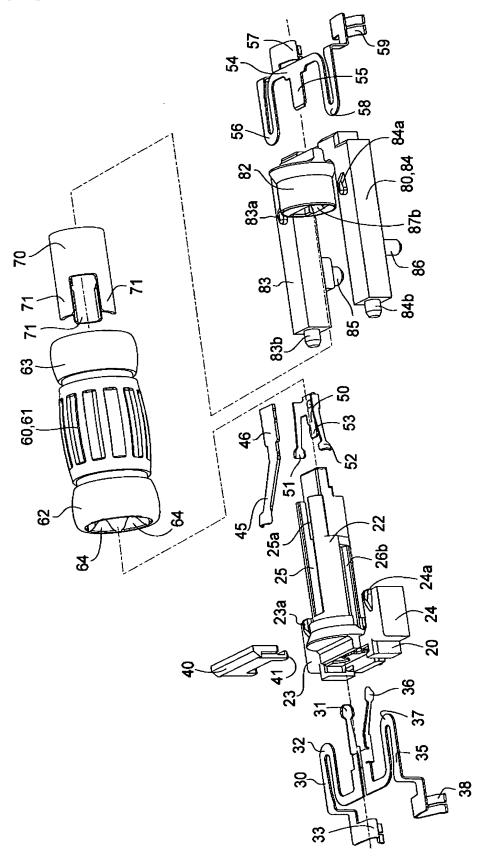


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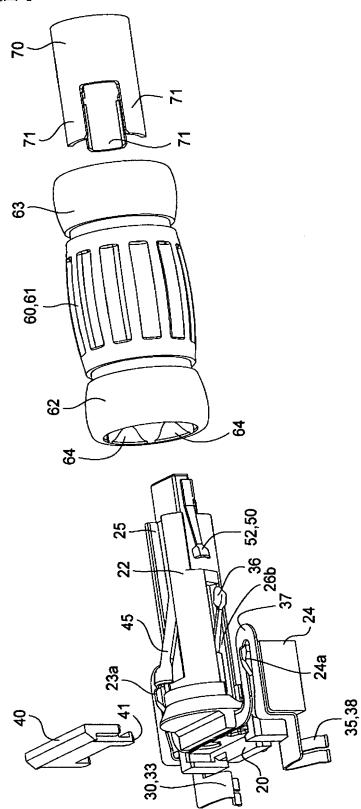




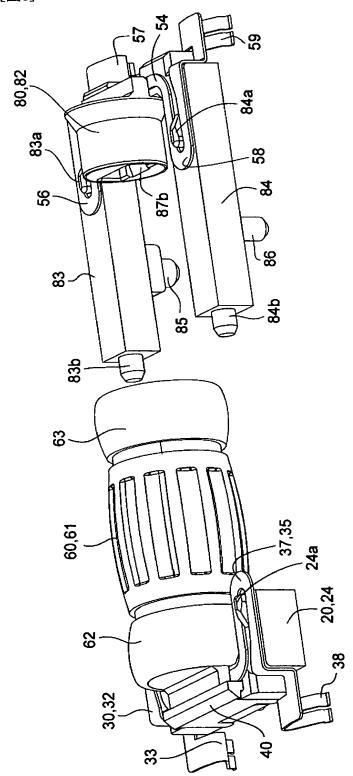
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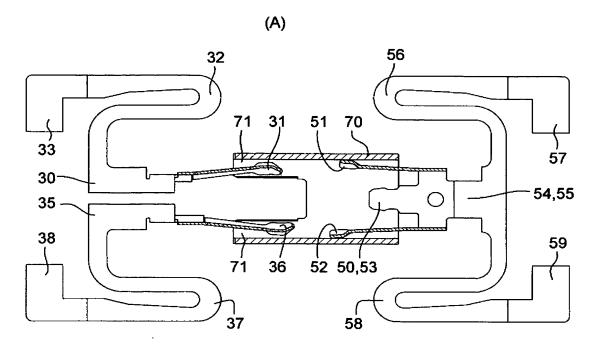


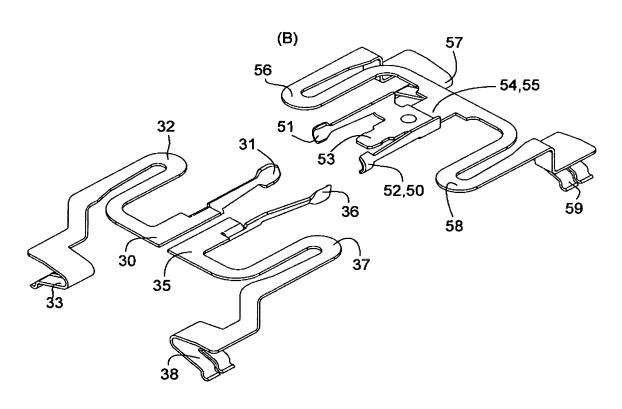


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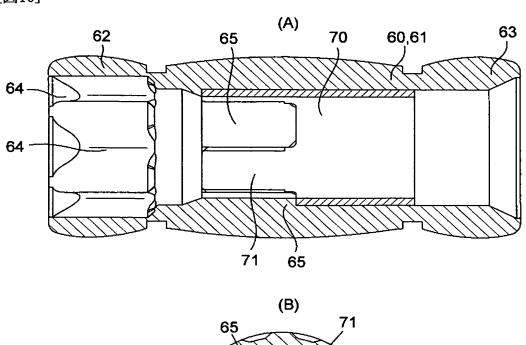


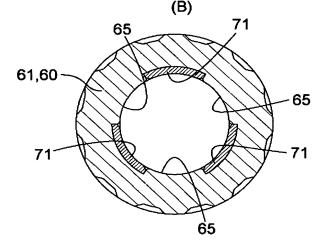
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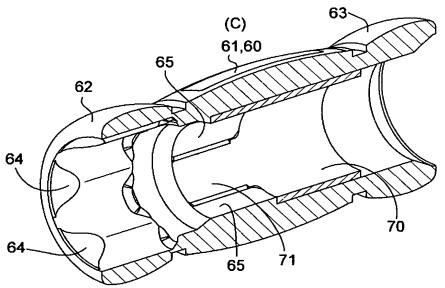




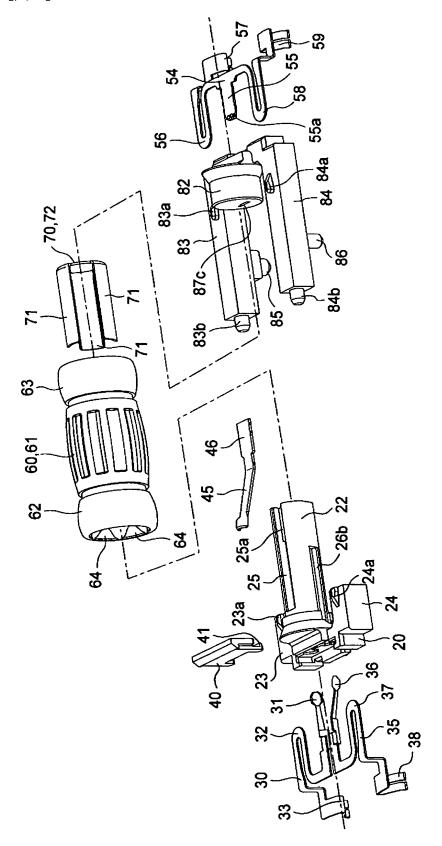
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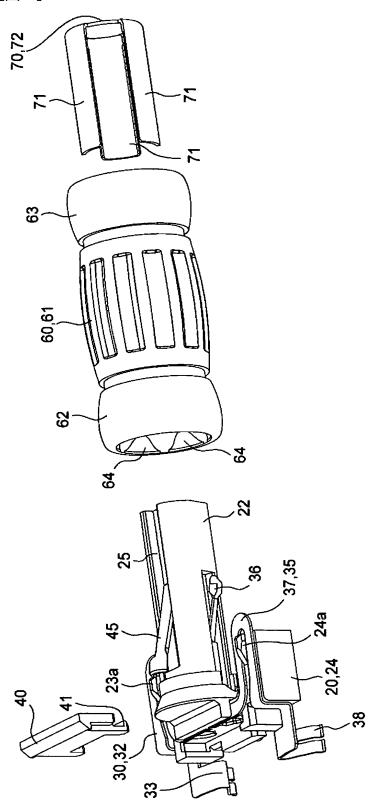




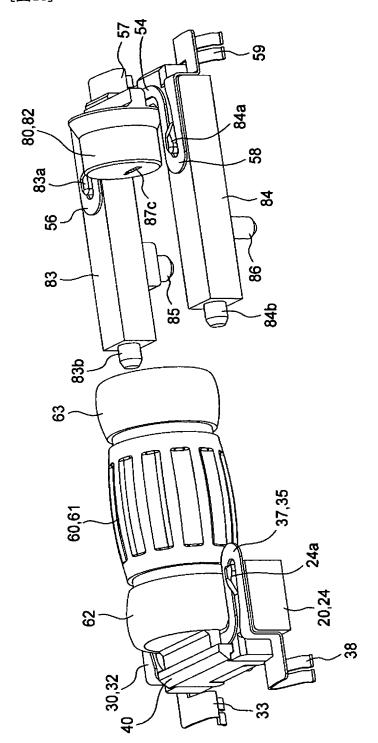
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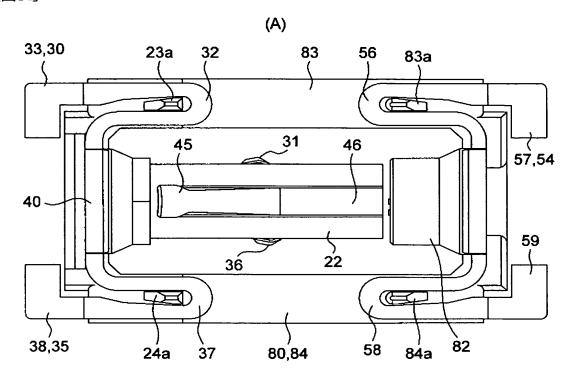
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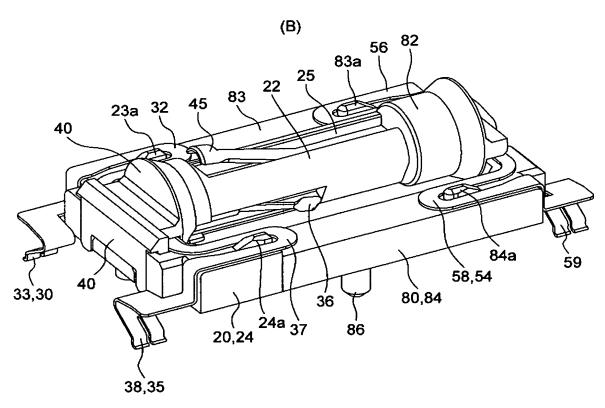


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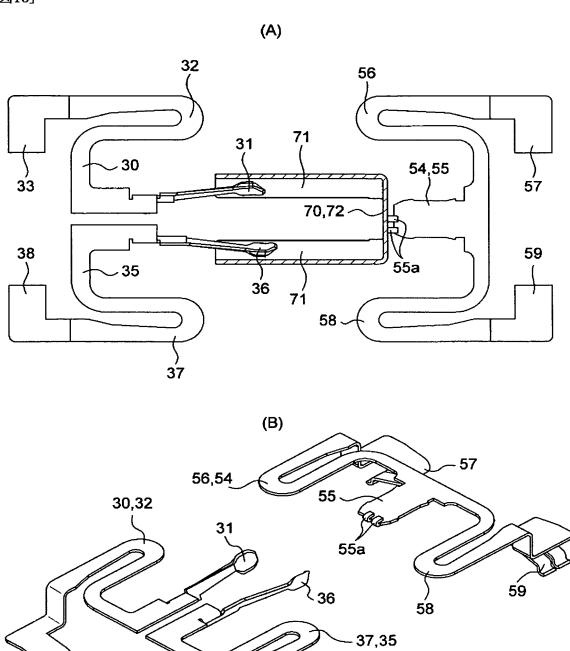


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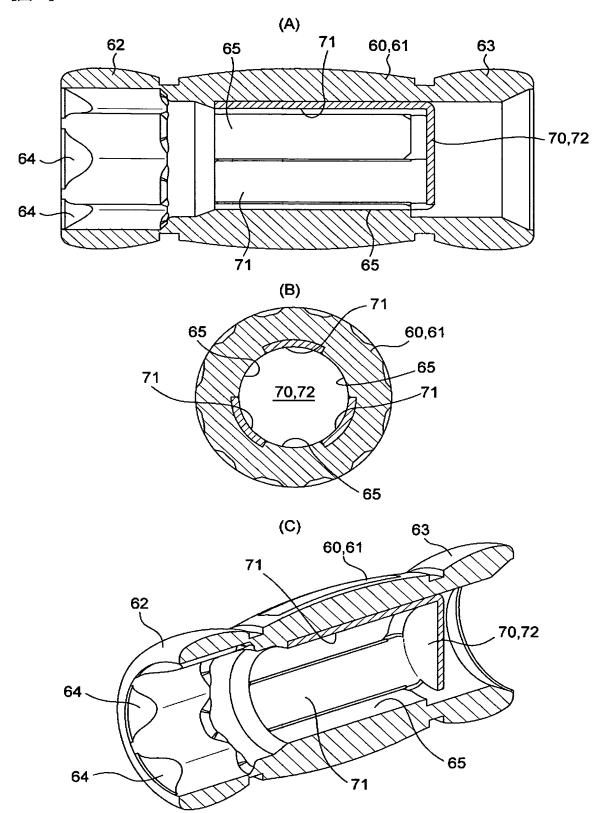


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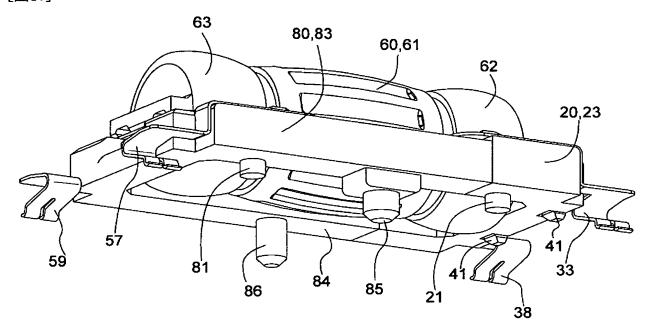


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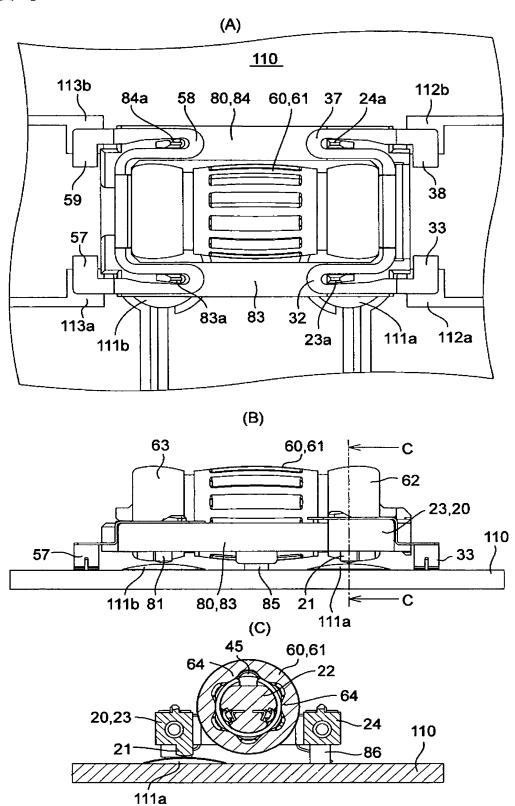
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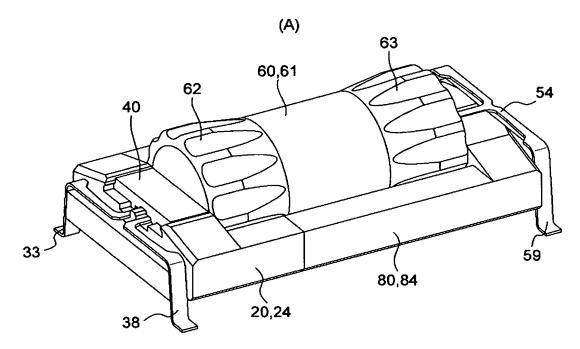
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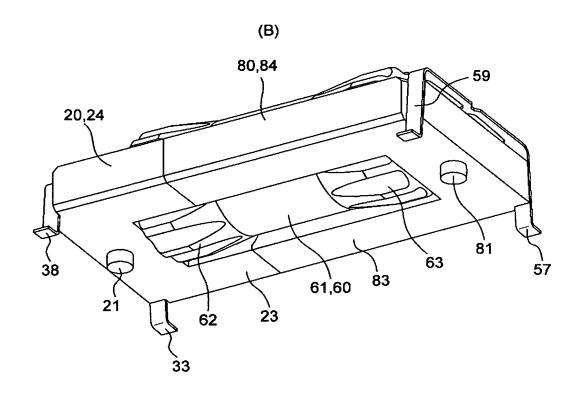


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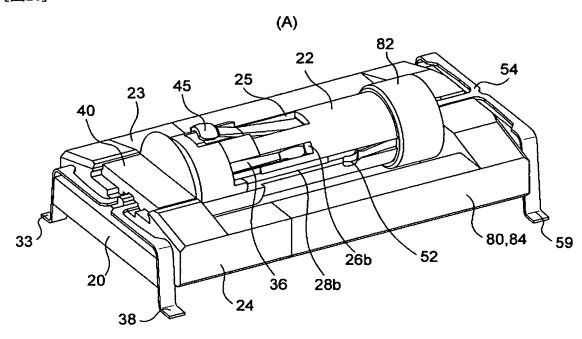


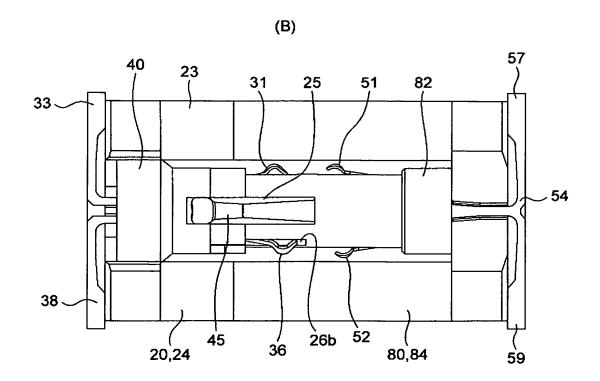
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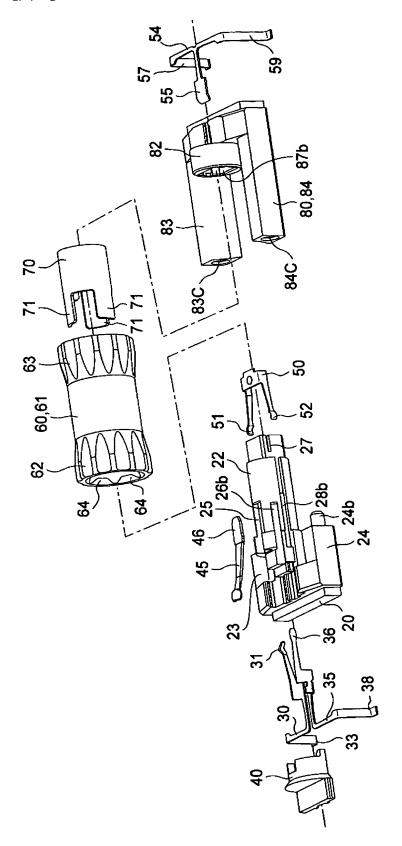


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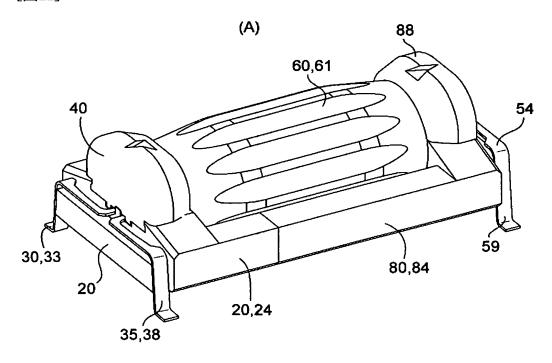


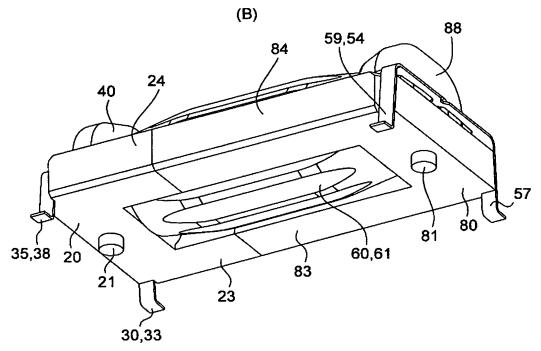


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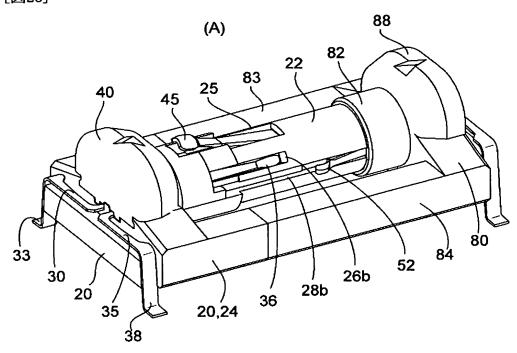


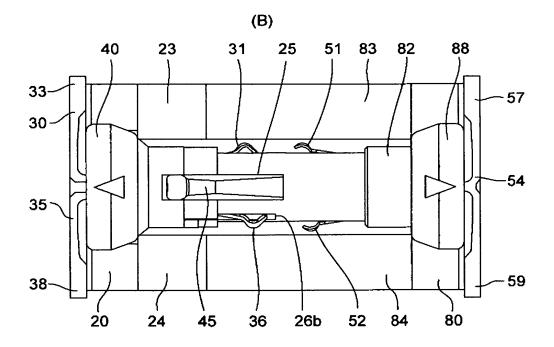
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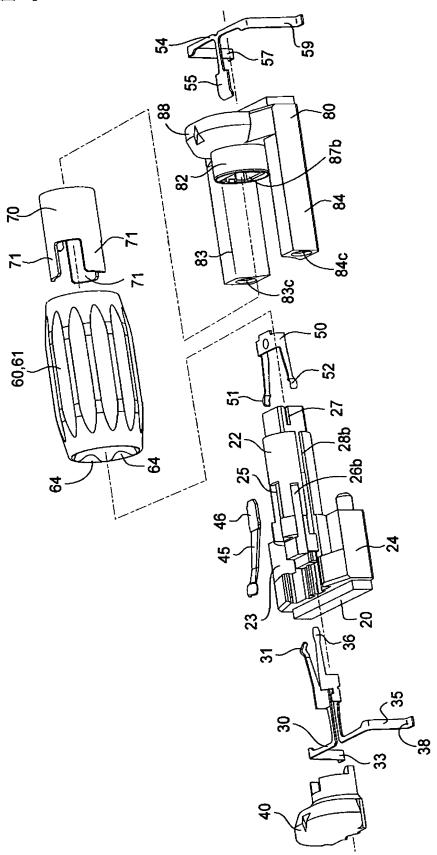


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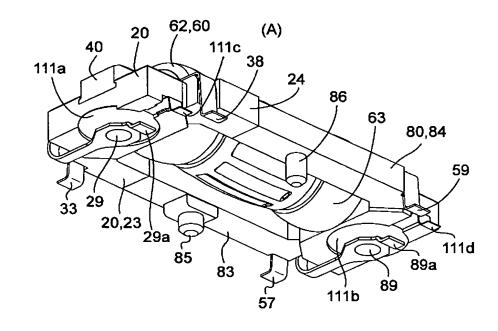


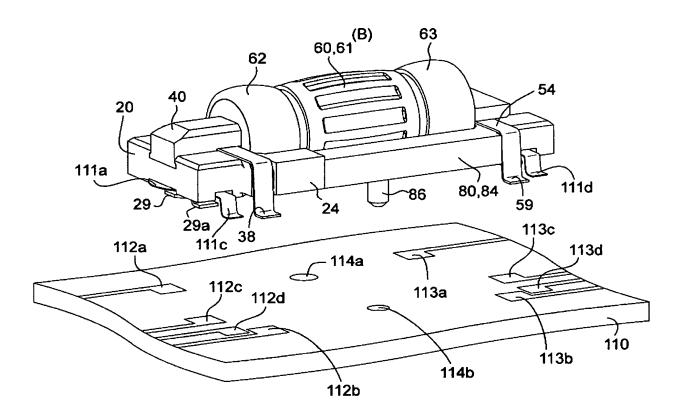


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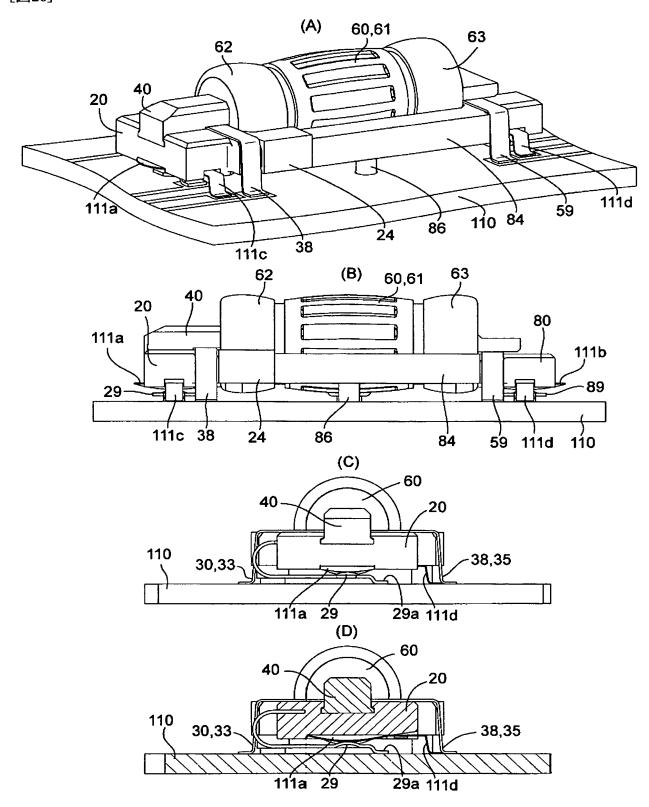


[図25]





[図26]



[図27]

